

Receipt

EMC 01-0650(3003)  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of John Davis Holder  
Serial No. 10/002,862  
Filed November 15, 2001  
Confirmation No. 4783  
For Intermittent Feeding Technique for Increasing  
the Melting Rate of Polycrystalline Silicon

Group Art Unit 1765



March 28, 2002

Office of Initial Patent Examination  
Customer Service Center  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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APR 12 2002  
TC 1700

Sir:

We have received the updated filing receipt in the above-referenced U.S. patent application.

The filing receipt still shows the title as Inermittent Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon; whereas the correct information is Intermittent Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon.

\* A marked up copy of the filing receipt is attached. Please send us a corrected filing receipt.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Edward J. Hejek".

Edward J. Hejek, Reg. No. 31,525  
SENNIGER, POWERS, LEAVITT & ROEDEL  
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## UNITED STATES PATENT AND TRADEMARK OFFICE

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EJH/SMR

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/002,862	11/15/2001	1765	2490	MEMC 01-0650 (3003)	4	96	6

000321  
 SENNIGER POWERS LEAVITT AND ROEDEL  
 ONE METROPOLITAN SQUARE  
 16TH FLOOR  
 ST LOUIS, MO 63102



CONFIRMATION NO. 4783

UPDATED FILING RECEIPT



\*OC000000007506507\*

Date Mailed: 02/21/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

John Davis Holder, Lake St. Louis, MO;

## Assignment For Published Patent Application

MEMC Electronic Materials, Inc.;

## Domestic Priority data as claimed by applicant

## Foreign Applications

If Required, Foreign Filing License Granted 12/26/2001

Projected Publication Date: 05/15/2003

Non-Publication Request: No

Early Publication Request: No

## Title

Inertial feeding technique for increasing the melting rate of polycrystalline silicon  
 Intermittent

## Preliminary Class

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BUNN